

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICELIST OF REFERENCES CITED BY APPLICANT(S)  
(Use several sheets if necessary)ATTY DOCKET NO.  
**35.C14384**APPLICATION NO.  
**09/506,289**APPLICANT(S)  
**MASAFUMI KYOGAKU ET AL.**FILING DATE  
**February 18, 2000**GROUP  
**2825**

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>KMP</i>	<b>4,904,895</b>	<b>2/27/90</b>	<b>Tsukamoto et al.</b>	<b>313</b>	<b>336</b>	<b>5/2/88</b>

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	<b>8-264112</b>	<b>10/11/96</b>	<b>Japan</b>			<b>Abstract</b>
	<b>8-162015</b>	<b>6/21/96</b>	<b>Japan</b>			<b>Abstract</b>
	<b>9-27268</b>	<b>1/28/97</b>	<b>Japan</b>			<b>Abstract</b>
	<b>9-27272</b>	<b>1/28/97</b>	<b>Japan</b>			<b>Abstract</b>
	<b>10-3848</b>	<b>1/6/98</b>	<b>Japan</b>			<b>Abstract</b>
	<b>10-3847</b>	<b>1/6/98</b>	<b>Japan</b>			<b>Abstract</b>
	<b>10-3853</b>	<b>1/6/98</b>	<b>Japan</b>			<b>Abstract</b>
	<b>10-3854</b>	<b>1/6/98</b>	<b>Japan</b>			<b>Abstract</b>
<b>EP</b>	<b>0 701 265 B1</b>	<b>3/13/96</b>	<b>EPO</b>			

## OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

	<b>W.P. Dyke et al., "Field Emission", Advances in Electronics and Electron Physics, Vol. VIII, 1956, pp. 89-185.</b>
	<b>H. Araki, et al., "Electroforming and Electron Emission of Carbon Thin Films", Journal of the Vacuum Soc. of Japan, Vol. 2-6, No. 1, 1983, pp. 22-29 (with English Abstract on p. 22).</b>
	<b>G. Dittmer, "Electrical Conduction and Electron Emission of Discontinuous Thin Films", Thin Solid Films, 9, 1972 pp. 317-328.</b>
	<b>M. Elinson, et al. "The Emission of Hot Electrons and the Field Emissions of Electrons From Tin Oxide", Radio Engineering and Electronic Physics, July 1965, pp. 1290-1298.</b>

EXAMINER *Allen*DATE CONSIDERED *11-7-00*

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy form with next communication to applicant.

FORM PTO 1449 (modified)

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICELIST OF REFERENCES CITED BY APPLICANT(S)  
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ATTY DOCKET NO.

35.C1348 2 6 2000

APPLICATION NO.

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	C.A. Mead, "Operation of Tunnel-Emission Devices," J. Applied Physics, Vol. 32, No. 4, April 1961, pp. 646-652.
	C.A. Spindt et al., "Physical Properties of Thin Films of Thin-film Field Emission Cathodes with Molybdenum Cases", J. Applied Physics, Vol. 47, No. 12, Dec. 1976, pp. 5248-5263.
	M. Hartwell et al., "Strong Electron Emission From Patterned Tin-Indium Oxide Films", IEDM, 1975, pp. 519-521.

EXAMINER

DATE CONSIDERED

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